

Method of Depositing a Protective Layer Over a Biaxially Textured Alloy Substrate and Composition Therefrom

Disclosure Number

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Technology Summary

Oxide films are epitaxially deposited on highly oxidizable biaxially textured alloys while precluding the formation of pernicious native oxides by first depositing an epitaxial layer of Ni, followed by deposition of the desired oxide.

Inventor

GOYAL, AMIT

Metals & Ceramics Division

Licensing Contact

DETRANA, ALEXANDER G

Rm 139, Bldg 4500N

1 Bethel Valley Road 6196

Oak Ridge, TN 37831

Office Phone: (865) 576-9682

E-Mail: DETRANAAG@ORNL.GOV
